

Retraction notice

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The Publisher wishes to retract the article, “A novel approach for the fabrication of low stress bi-morph RF MEMS switch”, by Hitesh Kumar Sharma and Shalu Rani, in the journal *Multidiscipline Modeling in Materials and Structures*, Vol. 13 No. 1, 2017.

It has come to the attention of the publisher that the article contains unattributed overlap with previously published articles, “Low loss STS based SPDT for X – Band applications”, by K. Maninder, A. Sharma, Dinesh Kumar, Surinder Singh and K. Rangra, DOI: 10.1016/j.proeng.2010.09.214 and “Design of Vertical Packaging Technology for RF MEMS Switch” by Deepak Bansal, Akshdeep Sharma, Maninder Kaur and K.J. Rangra, DOI: 10.1117/12.924260.

Emerald aims to publish original content that adds to the body of knowledge and asks authors to warrant upon submission that their work meets our originality guidelines. This article has been found to be in breach of this warranty and therefore we have made the decision to retract the article. The author and journal sincerely apologize for this.

